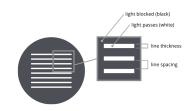


PTST050200P | DATASHEET

Stripes pattern, Photolitography



Opto Engineering® supplies a comprehensive range of projection patterns compatible with our LED illuminators.

PT projection patterns can be either laser-engraved, with 50 μ m geometrical accuracy, or photolitography-engraved for more demanding applications (2 μ m accuracy).



SPECIFICATIONS

Type		Stripes
Process		Photolitography
Substrate		Soda lime glass
Coating		Chrome on glass
Line spacing	(mm)	0.2
Line thickness	(mm)	0.05
Dot size	(mm x mm)	-
Geometrical accuracy	(µm)	2
Edge sharpness	(µm)	1.4

Circular aperture (LTPR)

Active Area	(mm)	11
Number of lines		44
Max line length	(mm)	11

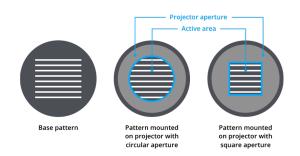
Square aperture (LTPRSM)

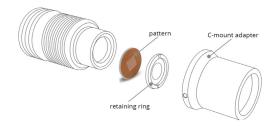
Active Area	(mm)	8 x 8
Number of lines		32
Max line length	(mm)	8

Mechanical specifications

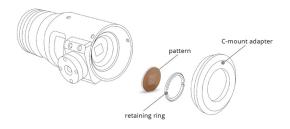
Diameter	(mm)	21
Thickness	(mm)	1.6

PTPR AND ACTIVE AREA





Pattern projector with circular aperture disassembled.



Pattern projector with square aperture disassembled.

COMPATIBLE PRODUCTS

Full list of compatible products available here.



A wide selection of innovative machine vision components.

All product specifications and data are subject to change without notice to improve reliability, functionality, design or other. Photos and pictures are for illustration purposes only. Data are reported by design, actual lens performance may vary due to manufacturing tolerances.